

P/1071-985

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

New York, New York

Takahiro OGUCHI

Date: April 13, 2000

Serial No.: To Be Assigned

Group Art Unit: ---

Filed: Herewith

Examiner: ---

For: **METHOD OF MANUFACTURING AN EXTERNAL FORCE DETECTION SENSOR**

Assistant Commissioner for Patents
Washington, D.C. 20231

JCS11 U.S. PTO
09/548414
04/13/00

#2
IDS

7/10/00

INFORMATION DISCLOSURE STATEMENT

Sir:

Submitted herewith is a copy of art together with a form listing the same for the convenience of the Examiner.

EXPRESS MAIL CERTIFICATE

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail Post Office to Addressee (mail label #EL157099597US) in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on April 13, 2000:

Dorothy Jenkins

Name of Person Mailing Correspondence

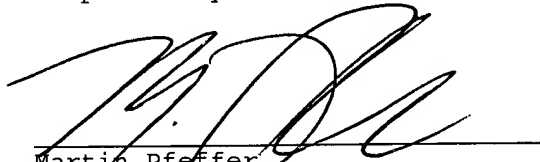
Dorothy Jenkins

Signature
April 13, 2000

Date of Signature

MP:jj
Enclosures

Respectfully submitted,



Martin Pfeffer

Registration No.: 20,808

OSTROLENK, FABER, GERB & SOFFEN, LLP

1180 Avenue of the Americas

New York, New York 10036-8403

Telephone: (212) 382-0700